IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/635,715
Filing Date ..... August 5, 2003
Inventor ..... Winston G. Scott
Assignee ..... Micron Technology, Inc
Group Art Unit ..... Unknown
Attorney's Docket No. MI22-2375
Title: Methods of Forming Transistor Gates; and Methods of Forming Programmable Read-Only Memory Constructions

TO: Group 2800
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9318 on the date shown below:

1. Certificate of Facsimile Transmission.
2. Supplemental Information Disclosure Statement w/PTO-1449.
3. Copy of cited reference.

Dated: Oct. 9, 2003 By: JoAnne O'Hare
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NUMBER OF PAGES IN FACSIMILE: 9

OFFICIAL

Inventor: **Winston G. Scott**

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, the Examiner's attention is directed to the reference listed on the attached Form PTO-1449 and a copy of which is attached. No admission is made regarding whether the submitted reference is prior art.

This Supplemental Information Disclosure Statement is being filed within three months of the filing date of the application or before the mailing of a first Office Action, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of this reference is respectfully requested.

Respectfully submitted,

Date: 10/9/03 Attorney: _____

David G. Latwesen, Ph.D.
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Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. M122-2375	SERIAL NO. 10/635,715
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT Winston G. Scott	
		FILING DATE August 5, 2003	GROUP Unknown

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
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	AL						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AR		Wolf, S., "Silicon Processing for the VLSI Era", Vol. 1: Process Technology, 1986 Lattice Press, pp. 434-437.
	AS		
	AT		

EXAMINER	DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.